Tool ID: 102 Tool Location: 103

### **Equipment Information Sheet**

# Category 3 LPCVD LTO410 - A3

Manager: Phil Infante 607-254-4926 Calls to staff phones their cell phones during the cell phones during their cell phones during the cell phone during the

Calls to staff phones will be automatically forwarded to their cell phones during accessible hours. At other times

leave a message or send them an email.

#### **SAFETY**

• The furnaces are run at elevated temperatures of 400-1200°C and use flammable, toxic, and corrosive gases.

#### **USAGE RESTRICTIONS**

- No changing of gas flows or process parameters without staff approval
- Max temperature of 450 C

#### SCHEDULING/SIGN-UP RESTRICTIONS

Minimum Tool Time: 90 minutes

• Reservation blocks greater than 8 hrs must be cleared by a MOS staff person prior to reserving the time

#### MATERIALS COMPATIBILITY CATEGORY

#### Tool Category 3: Silcion, III-V Compound Semiconductor, Glass and Metal Category

Allowed	Not Allowed
Tool category 1/1E and 2 materials	Glass Substrates
1	No CNF Class A or Class B metals-and oxides/compounds of i.e. (Magnesium, Zinc, Barium, Calcium)
PECVD and ALD Films	No High Vapor pressure materials
Cured organics and baked Photoresist	
Organic/Bio Materials prepped w/o Salt Buffers	

High Vapor Pressure Metals and Compounds are materials that have a vapor pressure above 1e-6 Torr at 400 C.

## **Additional Material Restrictions and Exceptions**

• Category 3 MOS CLEAN required prior to use

Last Updated: 08/06/2019